

Application Serial No. 09/885,393
Supplemental IDS

MI22-1694

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/885,393
Filing Date June 19, 2001
Inventor Richard Holscher et al.
Assignee Micron Technology, Inc.
Group Art Unit 1756
Examiner Kathleen Duda
Attorney's Docket No. MI22-1694
Title: Semiconductor Processing Methods

To: Mail Stop RCE
Commissioner for Patents
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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Reference -- See Attached Form PTO-1449

This Request for Continued Examination (RCE) Application is being filed in an abundance of caution to ensure consideration of the references listed on the attached form PTO-1449.

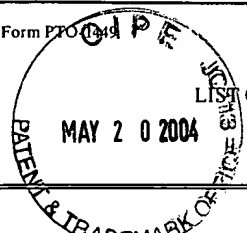
The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether the submitted reference is prior art. For the convenience of the Examiner we have enclosed a copy of the Japanese references and a copy of the article.

Respectfully submitted,

Dated: 5/20/04

By: 

Robert C. Hyta; Reg. No. 46,791

Form PTO-144 		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1694		SERIAL NO. 09/885,393	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Richard Holscher et al.		FILING DATE June 19, 2001	
				GROUP 1756			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	4,971,655	11/20/1990	Stefano et al.	156	659		
AB	6,153,504	11/28/2000	Shields et al.	438	613		
AC	6,087,064	07/11/00	Lin et al.	430	270.1		
AD	5,986,318	11/16/99	Kim et al.	257	437		
AE	6,498,084 B2	12/24/02	Bergemont	438	593		
AF	5,036,383	07/30/91	Mori	357	71		
AG							
AH							
AI							
AJ							
AK							
AL							
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AM	08-045926	16/02/1996	Japan (Abstract)				
AN	10-163083	19/06/1998	Japan			x	
AO	JP8051058	20/02/96	Japan (Abstract)				
AP	JP63316476	23/12/88	Japan (Abstract)				
AQ	JP8078322	22/03/96	Japan (Abstract)				
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR	Wolf, S., "Silicon Processing for the VLSI Era", Vol. 3; pg. 635					
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							